



Docket No.: 060188-0807

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of	:	Customer Number: 20277
Osamu KUSUMOTO, et al.	:	Confirmation Number: 4190
Application No.: 10/801,606	:	Group Art Unit: 2811
Filed: March 17, 2004	:	Examiner: HU, Shouxiang
For: SILICON CARBIDE SEMICONDUCTOR DEVICE AND METHOD FOR FABRICATING THE SAME		

AMENDMENT

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated October 4, 2005, having a three-month shortened statutory period for response set to expire January 4, 2006, please amend the above-identified application as follows.